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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Eiji NATORI

Application No.: 09/819,688

Docket No.: 109120

Filed: March 29, 2001

For: METHOD AND DEVICE FOR MANUFACTURING CERAMICS,
SEMICONDUCTOR DEVICE AND PIEZOELECTRIC DEVICE

REQUEST FOR CORRECTION OF PALM RECORDS

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Attached is a copy of the PTO date-stamped postcard to confirm the filing date of March 29, 2001.

Respectfully submitted,

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Date: October 12, 2001

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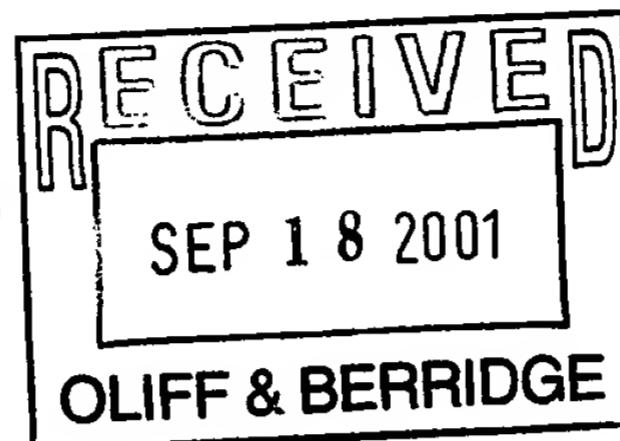

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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/819,688	07/19/2001 03/29/2001	1731	1204	109120	3	33	2

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CONFIRMATION NO. 3149
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Applicant(s)

Eiji Natori, Chino-shi, JAPAN;

Assignment For Published Patent Application

SEIKO EPSON CORPORATION;

Domestic Priority data as claimed by applicant
Foreign Applications

JAPAN 2000-91604 03/29/2000

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Projected Publication Date: 12/27/2001

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Non-Publication Request: No

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Early Publication Request: No

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Title

Method and device for manufacturing ceramics, semiconductor device and piezoelectric device

Preliminary Class

065